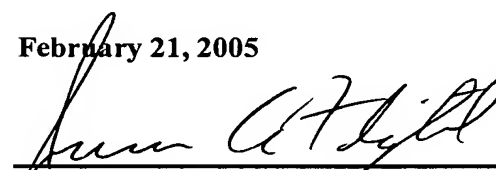




IFW

PATENT
Docket No. 20063/OG03-045

**IN THE UNITED STATES PATENT
AND TRADEMARK OFFICE**

Applicant(s):) I hereby certify that this paper and the
KIM et al.) documents referred to as enclosed
U.S. Serial No.: 10/747,599) therewith are being deposited with the
For: "Methods for Fabricating) United States Postal Service as first
Semiconductor Devices") class mail, postage prepaid, in an
Filed: December 29, 2003) envelope addressed to Commissioner
Group Art Unit: 1765) for Patents, P.O. Box 1450,
Examiner: Not Yet Assigned) Alexandria, Virginia 22313-1450 on
this date:
February 21, 2005

James A. Flight
Attorney for Applicant(s)
Registration No. 37,622

STATUS LETTER

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

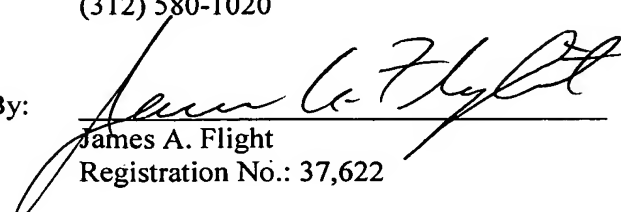
Kindly advise when an Office action can be expected in the above-referenced matter.

Respectfully submitted,

HANLEY, FLIGHT & ZIMMERMAN, LLC
USPTO Customer Number 34431
20 North Wacker Drive
Suite 4220
Chicago, Illinois 60606
(312) 580-1020

February 21, 2005

By:


James A. Flight
Registration No.: 37,622